

Form PTO-1449 U.S. Dept. of Commerce Patent & Trademark Office	Atty. Docket: 02-GR1-123	Serial No. Not Yet Assigned
List of Documents Cited by Applicant (Use several sheets if necessary)	Applicant: Nicolas CARRIERE et al.	
	Filing Date: HEREWITH	

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

AC	AA5	Tavel, B. et al., "Totally Silicided (COSi2) Polysilicon: a novel approach to very low-resistive gate (20MEGA/) without metal CMP nor etching", International Electron Devices Meeting 2001, IEDM. Technical Digest, IEEE, December 2, 2001, pp. 825-828, XP001075639.
AC	AA6	French Preliminary Search Report dated November 25, 2003 for French Application No. 03 03647.

Examiner: *Alb. Alb.* Date Considered: *12/20/05*

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.